

#8 [Signature]  
 [Signature]  
 T APPLICATION  
 cket No. 14917.D4

In re application of:

RECEIVED  
NOV 22 2002  
TC 1700

) Art Unit  
) 1723

For: INTEGRATED MONOLITHIC MICROFABRICATED  
ELECTROSPRAY AND LIQUID  
CHROMATOGRAPHY SYSTEM AND METHOD

Examiner: Ernest G. Therkorn

Commissioner for Patents  
Washington, DC 20231

Pursuant to 37 C.F.R. § 1.136(a), it is respectfully requested that the shortened statutory period which was set for responding to the Office Action dated May 29, 2002 be extended for three months until November 29, 2002.

If an additional extension of time is required, please consider this a petition therefore and charge any additional fees which may be required to Deposit Account No. 23-3178.

Dated this 18<sup>th</sup> day of November, 2002.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "D. Seeley", written over a horizontal line.

David O. Seeley  
Attorney for Applicant  
Registration No. 30,148

WORKMAN, NYDEGGER & SEELEY  
1000 Eagle Gate Tower  
60 East South Temple  
Salt Lake City, Utah 84111  
Telephone: (801) 533-9800

DOS:hb

W:\14917\1.4\HMB0000002095V001.doc